



Selected Papers from the ICAE 2019

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Deadline for manuscript
submissions:

closed (15 March 2020)

Message from the Guest Editors

Dear Colleagues,

This Special Issue will publish selected papers from the 5th International Conference on Advanced Electromaterials (ICAE 2019, <http://www.icae.kr/>), 5-8 November 2019, in Jeju, Korea.

The ICAE is a bi-annual conference series hosted by The Korean Institute of Electrical and Electronic Material Engineers focusing on all aspects of "electromaterials". We welcome manuscripts on the following topics:

- ferroelectric and piezoelectric materials and devices;
- green energy materials and devices;
- solar cells and fuel cells;
- functional thin films and devices;
- energy storage materials and devices;
- transparent electronics;
- printable electronics;
- smart nano-materials and devices;
- emerging optoelectronic materials and devices based on LEDs and OLEDs;
- biomedical materials and devices.

Papers attracting most interest at the conference, or that provide novel contributions, have been selected for publication in *Micromachines*. These papers will be peer-reviewed for validation of research results, developments and applications.





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Editor-in-Chief

Message from the Editor-in-Chief

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